

<b>Notice of References Cited</b>	Application/Control No. 09/878,476	Applicant(s)/Patent Under Reexamination HRINEVICH ET AL.	
	Examiner Monique M Wills	Art Unit 1746	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,558,728	09-1996	Kobayashi et al.	148/421
	C	US-			
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	www.semiconductor glossary.com: Semiconductor Glossary 2001
	V	Recent Progress in Silicon Carbide Semiconductor Electronics Technology (October 1995)
	W	Composites , Serdar S. Elgun (November 19, 1999).
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.